



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

May 16, 2026	
IGI Report Number	LG801605779
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	6.50 - 6.55 X 4.13 MM

GRADING RESULTS

Carat Weight	1.09 CARAT
Color Grade	E
Clarity Grade	VS 1
Cut Grade	EXCELLENT

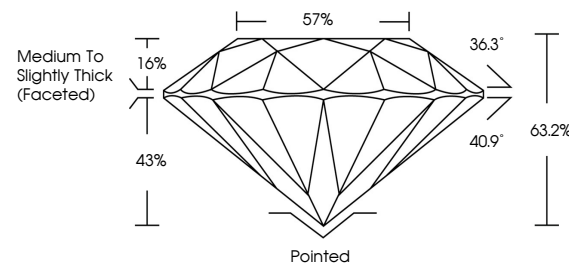
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG801605779

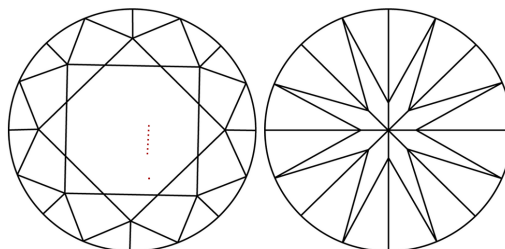
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG801605779
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

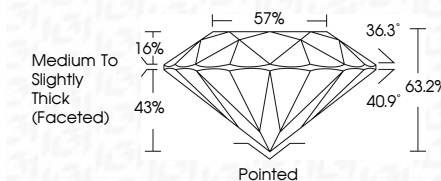
D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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	VIS 1	E	1.07 CARAT
	EXCELLENT		
	68.2%		
	57%		
	Medium to Slightly Thick (Faced)		
Culet	Poished		
Polish	EXCELLENT		
Symmetry	EXCELLENT		
Fluorescence	NONE		
Inscriptions(s)	#61 G6901665779		

Comments:
 - Mounted by Crown Diamond USA
 - Inscribed by Chemical Vapor Deposition (CVD) growth process.
 Type IIG